



FORM HDP-1449 (Based on Form PTO-1449)

**PATENT AND TRADEMARK OFFICE
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Sheet 1 of 2

ATTORNEY DOCKET NO.

8540G-000236

SERIAL NO.

10/004,322

APPLICANT

Ilona Busenbender

FILING DATE

October 25, 2001

GROUP

1745

U.S. PATENT DOCUMENTS

Ref. Desig.	Examiner's Initials	Document Number	Date	Name	Class/ Subclass	(If appropriate) Filing Date
n	1.	RE 37,284	07/17/01	Li, et al.	429/32	
n	2.	2002/081478	06-2002	Busenbender, Ilona	429-34	
n	3.	3,134,697	11/03/59	Niedrach	136/86	
n	4.	3,677,814	07/18/72	Gillery, et al.	117/211	
n	5.	4,146,657	03/27/79	Gordon	427/126	
n	6.	4,708,918	11/24/87	Fitzgerald, et al.	429/217	
n	7.	4,272,353	06/09/81	Lawrance, et al.	204/283	
n	8.	4,510,219	04/09/85	Rowlette	—	
n	9.	4,973,358	11/27/90	Jin, et al.	75/415	
n	10.	5,272,017	12/21/93	Swathirajan, et al.	429/33	
n	11.	5,624,769	04/29/97	Li et al.	429/32	
n	12.	5,800,946	09/01/98	Grosvenor, et al.	429/210	
n	13.	5,942,347	08-1999	Koncar, et al.	429/30	
n	14.	5,981,072	11/09/99	Mercuri, et al.	—	
n	15.	6,037,074	03-2000	Mercuri, et al.	429/34	
n	16.	6,077,623	06/20/00	Grosvenor, et al.	429/210	
n	17.	6,096,450	08/01/00	Walsh	429/34	
n	18.	6,103,413	08/15/00	Hinton, et al.	429/32	
n	19.	6,146,780	11/14/00	Cisar, et al.	429/34	
n	20.	6,248,467	06/19/01	Wilson et al.	429/39	

Examiner:

Date Considered:

8/25/04

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FOREIGN PATENT DOCUMENTS

Ref. Desig.	Examiner's Initials	Document Number	Date	Country	Class/ Subclass	Translation Yes	No
1.	<i>n</i>	EP-A-97202340.0 ²⁰²³⁴³	11/11/92	Europe	—	X	
2.	<i>n</i>	WO 96/11802	04/25/96	WIPO	B32B	X	

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)

Ref. Desig.	Examiner's Initials	
1.	<i>n</i>	R. Gordon, Chemical Vapor Deposition of Coatings on Glass, Journal of Non-Crystalline Solids 218 (1997) 81-91
2.	<i>n</i>	Acosta et al., "About the structural, optical and electrical properties of SnO ₂ films produced by spray pyrolysis from solutions with low and high contents of fluorine," Thin Solid Films 288 (1996) 1-7
3.	<i>n</i>	Ma et al., "Electrical and optical properties of F-doped textured SnO ₂ films deposited by APCVD," Solar Energy Materials and Solar Cells 40 (1996) 371-380
4.	<i>n</i>	Sekhar et al., "Preparation and study of doped and undoped tin dioxide films by the open air chemical vapor deposition technique," Thin Solid Films 307 (1997) 221-227
5.	<i>n</i>	Mientus et al., "Structural, electrical and optical properties of SnO _{2-x} F-layers deposited by DC-reactive magnetron-sputtering from a metallic target in Ar-O ₂ /CF ₄ mixtures," Surface and Coatings Technology 98 (1998) 1267-1271
6.	<i>n</i>	Suh, et al., "Atmospheric-pressure chemical vapor distribution of fluorine-doped tin oxide thin films" Thin Solid Films 345 (1999) 240-243
7.	<i>n</i>	Perry et al., Chemical Engineers' Handbook Fifth Edition (1973) pp. 68-69
8.	<i>n</i>	International Search Report dated 6/20/2003; Int'l Appln. No. PCT/US03/05609, published with WO 03/75387, 9/12/03.

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